

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Applicant:

Shmuel BEN MUVHAR

Serial No.:

10/523,966

Filed:

October 06, 2005

For:

FLOW REDUCING IMPLANT

Examiner:

KOTINI, PAVITRA



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Group Art Unit: 3731

Attorney  
Docket: 34922

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL  
INFORMATION DISCLOSURE STATEMENT

Sir:

Enclosed is a PTO Form 1449 which lists citations which may be material to the patentability and examination of the above identified application. Also enclosed are copies of the references cited. These are submitted in compliance with the duty of disclosure defined in 37 CFR 1.56. The Examiner is requested to make these citations of official record in this application.

This Supplemental Information Disclosure Statement under 37 CFR 1.56 is not to be construed as a representation that a search has been made, that additional matter which is material to the examination of this application does not exist, or that any or more of these citations constitutes prior art.

Respectfully submitted,

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Dated: January 1, 2008